

GMP01-WA02 Silicon Pressure Sensor

General Introduction

GMP01-WA02 is an absolute type silicon pressure sensor especially designed for applications requiring highly-precision pressure measurement from 30 to 110kPa. The pressure sensor is based on the industry-recognized piezo-resistive technology featuring long-term stability and EMC robustness. Its small size, $0.9 \times 0.9 \text{ mm}^2$, benefits the miniature packages.

Features

O Operation range: $30\sim110$ kPa O Small size: 0.9×0.9 mm²

O Absolute type sensor O Low cost

O Constant current or constant voltage drive

Applications

O Ascending/descending speed estimation O

• Altimetry and barometry

• Activity tracking for health care applications

Indoor navigation for floor/elevator detection

O GPS applications

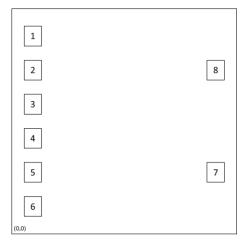


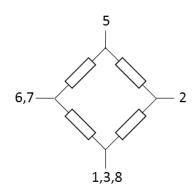
Specifications

Parameter	Symbol	Condition	Min.	Тур.	Max.	Unit
Operation voltage	Vin		_	3	5	V
Operation current	Ι0		_	0.5	1	mA
Bridge impedance			5	5.4	6	$\mathrm{k}\Omega$
Pressure range			30		110	kPa
Full scale span	FS	Vin=3V	80	110	140	mV
Offset		1ATM (~100kPa)	70	100	130	mV
Linearity			-0.3	±0.15	+0.3	%FS
TC span		Constant voltage	-0.17	-0.22	-0.27	%FS/°C
		Constant current	-0.08	±0.02	+0.08	%FS/°C
TC offset			-0.08	-0.05	+0.08	%FS/°C
Burst pressure					ЗХ	Rated FS
Temperature range			-40	25	+85	°C
Storage temperature			-40		+125	°C



Pads layout and definition





O Die size: 0.9mm×0.9mm (without scribe line)

O Pad size: 70μm×80μmO Scribe line: 80μm

Pin#	Name	Description	X	Y
1	GND	Ground pad	85	790
2	Vout-	Output voltage -	85	654
3	GND	Ground pad	85	518
4	NC	No connection inside	85	382
5	Vin	Power supply in	85	246
6	Vout+	Output voltage +	85	110
7	Vout+	Output voltage +	815	246
8	GND	Ground pad	815	654